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SEMICONDUCTOR LASER DEVICE

BACKGROUND OF THE INVENTION

The present invention relates to a semiconductor laser device including a semiconductor laser chip.

A semiconductor laser device provides an optical output by operating a semiconductor laser chip with the application of a forward bias thereto. However, if a surge voltage has been applied to the semiconductor laser chip, then an excessive amount of surge current flows through the semiconductor laser chip in the forward direction, resulting in an excessive optical output. Consequently, the performance of the semiconductor laser chip itself deteriorates.

First, a conventional surge-suppressive semiconductor laser device will be described with reference to Figures 8(a) and 8(b).

Figure 8(a) is perspective view of a conventional semiconductor laser device. As shown in Figure 8(a), a semiconductor laser chip 23, made of GaAlAs, is formed over a ceramic capacitor 21 with a laser mount 22 interposed therebetween. The ceramic capacitor 21 is connected in parallel to the semiconductor laser chip 23 via a wire 24.

Figure 8(b) is circuit diagram of the conventional semiconductor laser device. As shown in Figure 8(b), the semiconductor laser chip 23 and the ceramic capacitor 21 are

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connected in parallel to each other. When a surge voltage is applied to the semiconductor laser device, the ceramic capacitor 21 absorbs a surge current, which is a transient current, thus preventing an excessive amount of current from
5 being supplied to the semiconductor laser chip 23. Also, if the impedance of the ceramic capacitor 21 is made sufficiently smaller than that of the semiconductor laser chip 23 by increasing the capacitance of the ceramic capacitor 21, then the surge current can be absorbed even more effectively.

10 In the conventional semiconductor laser device, in order to absorb the surge current sufficiently, the impedance of the ceramic capacitor 21 should be smaller than that of the semiconductor laser chip 23. Thus, the capacitance of the ceramic capacitor 21 should be set larger than the junction
15 capacitance of the semiconductor laser chip 23.

However, suppose a reference voltage, applied to a laser driver for driving the semiconductor laser chip 23, fluctuates; the semiconductor laser chip 23 is superimposed with a radio frequency voltage; or a pulse voltage is applied to the
20 semiconductor laser chip 23 when the capacitance of the ceramic capacitor 21 is larger than the junction capacitance of the semiconductor laser chip 23. In each of these situations, radio frequency components leak to the ceramic capacitor 21 connected in parallel to the semiconductor laser chip 23. As
25 a result, the response characteristics of the semiconductor

laser chip 23 adversely deteriorate.

SUMMARY OF THE INVENTION

An object of the present invention is providing a surge-
5 suppressive semiconductor laser device exhibiting excellent
response characteristics even if a radio frequency voltage
has been superimposed or if the device is modulated with
pulses.

In order to achieve this object, a first exemplary semi-
10 conductor laser device according to the present invention in-
cludes: a semiconductor laser chip including an anode and a
cathode; and a field effect transistor. The anode is connect-
ed to the drain of the field effect transistor. The gate of
the field effect transistor is connected to the drain of the
15 field effect transistor. And the cathode is connected to the
source of the field effect transistor.

In the first semiconductor laser device, when a voltage
exceeding a threshold voltage of the field effect transistor
is applied to the semiconductor laser chip, a surge current
20 flows through, and can be absorbed by, the field effect tran-
sistor. Also, since the field effect transistor starts to
operate only when a voltage exceeding the threshold voltage
of the field effect transistor is applied to the semiconduc-
tor laser chip, the response of the semiconductor laser chip
25 does not deteriorate even if a radio frequency voltage has

been superimposed or the device has been modulated with a pulse voltage.

A second exemplary semiconductor laser device according to the present invention includes: a semiconductor laser chip including an anode and a cathode; and a bipolar transistor. The anode is connected to the collector of the bipolar transistor, and the cathode is connected to the emitter of the bipolar transistor.

In the second semiconductor laser device, when a voltage exceeding an avalanche voltage between the collector and the emitter of the bipolar transistor is applied to the semiconductor laser chip, a surge current flows through, and can be absorbed by, the bipolar transistor. Also, the bipolar transistor starts to operate only when a voltage exceeding the avalanche voltage between the collector and emitter of the bipolar transistor is applied to the semiconductor laser chip. Thus, the response of the semiconductor laser chip does not deteriorate even if a radio frequency voltage has been superimposed or the device has been modulated with a pulse voltage.

A third exemplary semiconductor laser device according to the present invention includes: a semiconductor laser chip including an anode and a cathode; a field effect transistor; and a bipolar transistor. The anode is connected to the collector of the bipolar transistor. The cathode is connected to

the emitter of the bipolar transistor. The drain of the field effect transistor is connected to the collector of the bipolar transistor. The source of the field effect transistor is connected to the base of the bipolar transistor. And the gate
5 of the field effect transistor is connected to the drain of the field effect transistor.

In the third semiconductor laser device, only when a voltage exceeding a threshold voltage of the field effect transistor is applied to the semiconductor laser chip, the
10 field effect transistor starts to operate. In response thereto, a base current is injected into the bipolar transistor and a surge current flows through, and can be absorbed by, the bipolar transistor. Also, since the field effect transistor starts to operate only when a voltage exceeding
15 the threshold voltage of the field effect transistor is applied to the semiconductor laser chip, the response of the semiconductor laser chip does not deteriorate even if a radio frequency voltage has been superimposed or the device has been modulated with a pulse voltage.

20 A fourth exemplary semiconductor laser device according to the present invention includes: a semiconductor laser chip including an anode and a cathode; and a surge absorber including a diode and a capacitor that are connected in series to each other. The anode is connected to one terminal of the
25 surge absorber. The cathode is connected to the other termi-

nal of the surge absorber. And the diode is connected to the semiconductor laser chip to have the same polarity.

The fourth semiconductor laser device includes a surge absorber including a diode and a capacitor that are connected
5 in series to each other. Since the bias voltage of the diode is relatively low during the normal operation of the semiconductor laser device, the impedance of the diode is larger than that of the semiconductor laser chip. Thus, it is possible to prevent the modulated components from leaking from the laser
10 chip into the surge absorber even if a radio frequency voltage has been superimposed, for example. As a result, the response characteristics of the semiconductor laser chip do not deteriorate.

A fifth semiconductor laser device according to the present invention includes: a semiconductor laser chip including
15 an anode and a cathode; a first diode including an anode and a cathode; and a second diode including an anode and a cathode. The anodes of the first and second diodes are connected in common. The anode of the semiconductor laser chip is connected
20 ed to the cathode of the first diode. And the cathode of the semiconductor laser chip is connected to the cathode of the second diode.

In the fifth semiconductor laser device, when a surge voltage is applied to the semiconductor laser device, breakdown happens in the first diode connected to the semiconductor
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laser chip to have mutually reverse polarities. On the other hand, the second diode, connected to the semiconductor laser chip to have the same polarity, is forward biased. As a result, the surge current can be absorbed. Also, even if a bias
5 voltage varies or a reference voltage, applied to a laser driver, fluctuates due to the superposition of a radio frequency voltage, the bias voltage of the second diode hardly changes. Thus, it is possible to prevent the modulated components from leaking from the laser chip into the surge absorber
10 even if a radio frequency voltage has been superimposed, for example. As a result, the response characteristics of the semiconductor laser chip do not deteriorate.

BRIEF DESCRIPTION OF THE DRAWINGS

15 Figure 1(a) is a perspective view of a semiconductor laser device according to a first embodiment of the present invention; and

Figure 1(b) is a circuit diagram of the semiconductor laser device of the first embodiment.

20 Figure 2(a) is a circuit diagram illustrating a circuit for applying a surge voltage to the semiconductor laser device of the first embodiment to test the device; and

Figure 2(b) is a graph illustrating a relationship between a surge voltage and a surge current flowing through the
25 semiconductor laser chip in the semiconductor laser device of

the first embodiment.

Figure 3(a) is a perspective view of a semiconductor laser device according to a second embodiment of the present invention; and

5 Figure 3(b) is a circuit diagram of the semiconductor laser device of the second embodiment.

Figure 4(a) is a cross-sectional view of a semiconductor laser device according to a third embodiment of the present invention; and

10 Figure 4(b) is a circuit diagram of the semiconductor laser device of the third embodiment.

Figure 5(a) is a cross-sectional view of a semiconductor laser device according to a fourth embodiment of the present invention; and

15 Figure 5(b) is a circuit diagram of the semiconductor laser device of the fourth embodiment.

Figure 6(a) is a cross-sectional view of a semiconductor laser device according to a fifth embodiment of the present invention; and

20 Figure 6(b) is a circuit diagram of the semiconductor laser device of the fifth embodiment.

Figure 7(a) is a cross-sectional view of a semiconductor laser device according to a sixth embodiment of the present invention; and

25 Figure 7(b) is a circuit diagram of the semiconductor

laser device of the sixth embodiment.

Figure 8(a) is a perspective view of a conventional semiconductor laser device; and

Figure 8(b) is a circuit diagram of the conventional semiconductor laser device.

DESCRIPTION OF THE PREFERRED EMBODIMENTS

EMBODIMENT 1

Figure 1(a) is a perspective view of a semiconductor laser device according to a first exemplary embodiment of the present invention; and Figure 1(b) is a circuit diagram of the semiconductor laser device of the first embodiment.

As shown in Figure 1(a), a semiconductor laser chip 1, made of GaAlAs, is provided over a package 3 with a conductive laser mount 2 interposed therebetween. A semiconductor substrate 5, including an n-channel field effect transistor 4 operating in an enhancement mode thereon, is also provided on the package 3. The semiconductor laser chip 1 and the field effect transistor 4 are connected to each other via a wire 6.

As shown in Figure 1(b), the anode of the semiconductor laser chip 1 is connected to the gate and the drain of the field effect transistor 4, while the cathode of the semiconductor laser chip 1 is connected to the source of the field effect transistor 4.

In this case, a bias voltage of the semiconductor laser

chip 1 is ordinarily in the range from 1.5 V to 2.5 V. By setting the threshold voltage of the field effect transistor 4 higher than the bias voltage of the semiconductor laser chip 1, the field effect transistor 4 does not start to operate so long as the semiconductor laser chip 1 operates at the bias voltage. In other words, the field effect transistor 4 does not operate unless a voltage exceeding the threshold voltage of the field effect transistor 4 is applied to the semiconductor laser device. Accordingly, the response of the semiconductor laser chip 1 does not deteriorate even if a radio frequency voltage has been superimposed or the device has been modulated with a pulse voltage.

Next, the results of an experiment, where a surge voltage is applied to the semiconductor laser device of the first embodiment to measure a surge current flowing through the semiconductor laser chip 1, will be described.

Figure 2(a) illustrates a circuit for applying a surge voltage to the semiconductor laser device. This circuit includes a capacitor with a capacitance of 200 pF and a switch. When the switch is turned ON, electrical charges, which have been stored in the capacitor, start to flow into the semiconductor laser device.

Figure 2(b) illustrates a relationship between a surge voltage applied to the semiconductor laser device and (the peak value of) a surge current flowing through the semicon-

ductor laser chip 1. In Figure 2(b), the line A represents a surge current flowing through the semiconductor laser chip 1 where the semiconductor laser device includes only the semiconductor laser chip 1. The line B illustrates a surge current flowing through the semiconductor laser chip 1 where the threshold voltage of the field effect transistor 4 is 10 V. And the line C illustrates a surge current flowing through the semiconductor laser chip 1 where the threshold voltage of the field effect transistor 4 is 3 V.

10 Setting the threshold voltage of the field effect transistor 4 at 10 V, when a surge voltage exceeding 10 V is applied to the semiconductor laser device, a voltage applied to the transistor 4 exceeds the threshold voltage thereof. As a result, a surge current flows through the transistor 4. Thus, 15 as compared with a semiconductor laser device including only the semiconductor laser chip 1, the surge current flowing into the semiconductor laser chip 1 can be reduced.

 If the threshold voltage of the field effect transistor 4 is lowered to 3 V, then a surge current flows through the 20 transistor 4 only by applying a surge voltage exceeding 3 V to the semiconductor laser device. As a result, the surge current can be absorbed even more effectively.

 The threshold voltage of the field effect transistor 4 should preferably be in the range from 0.2 V to 5.0 V and 25 higher than the bias voltage of the semiconductor laser chip 1.

The reason is as follows. If the threshold voltage of the field effect transistor 4 is lower than 5 V, then the surge current would be absorbed more effectively. This is because the lower the threshold voltage is, the faster the field effect transistor 4 can respond to the rise of the surge voltage. However, as the threshold voltage of the field effect transistor 4 is closer to the bias voltage of the semiconductor laser chip 1, the transistor 4 is more and more likely to operate accidentally. This is because if a radio frequency voltage has been superimposed in such a situation, then the bias voltage varies or the reference voltage, applied to a laser driver, fluctuates easily. Thus, the threshold voltage of the field effect transistor 4 should be higher than the bias voltage of the semiconductor laser chip 1 by at least 0.2 V and preferably more.

In the first embodiment, the field effect transistor 4 does not operate so long as a voltage lower than the threshold voltage of the field effect transistor 4 is applied to the semiconductor laser device. Accordingly, radio frequency components do not leak into the field effect transistor 4. In actuality, when the semiconductor laser device was modulated with pulses, the waveform of a current flowing through the device and the intensity waveform of output optical power thereof exhibited excellent response at the rise and fall times of the pulses.

If the resistance between the drain and source of the field effect transistor 4 is equal to or lower than the series resistance of the semiconductor laser chip 1, then most of the surge current, flowing through the semiconductor laser device, is that flowing through the field effect transistor 4. As a result, the surge current can be absorbed a lot more effectively. Accordingly, the on-resistance between the drain and source of the field effect transistor 4 is preferably 5Ω or less.

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EMBODIMENT 2

Figure 3(a) is a perspective view of a semiconductor laser device according to a second embodiment of the present invention; and Figure 3(b) is a circuit diagram of the semiconductor laser device of the second embodiment.

As shown in Figure 3(a), a semiconductor laser chip 1, made of GaAlAs, is provided over a package 3 with a conductive laser mount 2 interposed therebetween. A semiconductor substrate 5, including an npn bipolar transistor 7 thereon, is also provided on the package 3. The semiconductor laser chip 1 and the bipolar transistor 7 are connected to each other via a wire 6.

As shown in Figure 3(b), the anode of the semiconductor laser chip 1 is connected to the collector of the bipolar transistor 7, while the cathode of the semiconductor laser

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chip 1 is connected to the emitter of the bipolar transistor 7.

By setting an avalanche voltage between the collector and emitter of the bipolar transistor 7 higher than the bias voltage of the semiconductor laser chip 1, the bipolar transistor 7 does not start to operate so long as the semiconductor laser chip 1 operates at the bias voltage. In other words, the bipolar transistor 7 does not operate unless a voltage exceeding the avalanche voltage between the collector and emitter of the bipolar transistor 7 is applied to the semiconductor laser device. Accordingly, the response of the semiconductor laser chip 1 does not deteriorate even if a radio frequency voltage has been superimposed or the device has been modulated with a pulse voltage.

Because of the same reason as that described in the first embodiment, the avalanche voltage between the collector and emitter of the bipolar transistor 7 should preferably be higher than the bias voltage of the semiconductor laser chip 1 by 0.2 V to 5.0 V.

In the second embodiment, the bipolar transistor 7 does not operate so long as a voltage lower than the absolute value of the avalanche voltage between the collector and emitter of the bipolar transistor 7 is applied to the semiconductor laser device. Accordingly, radio frequency components do not leak into the bipolar transistor 7. In actuality, when the

semiconductor laser device was modulated with pulses, the waveform of a current flowing through the device and the intensity waveform of output optical power thereof exhibited excellent response at the rise and fall times of the pulses.

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EMBODIMENT 3

Figure 4(a) is a cross-sectional view of a semiconductor laser device according to a third embodiment of the present invention; and Figure 4(b) is a circuit diagram of the semiconductor laser device of the third embodiment.

As shown in Figure 4(a), a semiconductor laser chip 1, made of GaAlAs, is provided over a package 3 with a conductive laser mount 2 interposed therebetween. A semiconductor substrate 5, including an n-channel field effect transistor 4 operating in an enhancement mode and an npn bipolar transistor 7 thereon, is also provided on the package 3. The semiconductor laser chip 1 is connected to the field effect transistor 4 and to the bipolar transistor 7 by connecting respective wires 6 to associated electrodes 10 formed in the openings of an insulating film 9 on the semiconductor substrate 5.

As shown in Figure 4(b), the drain and gate of the field effect transistor 4 and the collector of the bipolar transistor 7 are all connected to the anode of the semiconductor laser chip 1. The cathode of the semiconductor laser chip 1

is connected to the emitter of the bipolar transistor 7. The source of the field effect transistor 4 is connected to the base of the bipolar transistor 7. In this case, the bias voltage of the semiconductor laser chip 1 is 2 V, while the
5 threshold voltage of the field effect transistor 4 is 3 V.

When a surge voltage exceeding 3 V is applied to the semiconductor laser device, the field effect transistor 4 starts to operate and a base current is injected to the bipolar transistor 7, which also starts to operate. We confirmed
10 based on the results of experiments that when the surge current flows through the bipolar transistor 7 in this manner, then the surge current supplied to the semiconductor laser device can be absorbed by the transistor 7.

In the third embodiment, the field effect transistor 4
15 does not operate so long as a voltage lower than the threshold voltage of the field effect transistor 4 is applied to the semiconductor laser device. Accordingly, radio frequency components do not leak into the field effect transistor 4. In actuality, when the semiconductor laser device was modu-
20 lated with pulses, the waveform of a current flowing through the device and the intensity waveform of output optical power thereof exhibited excellent response at the rise and fall times of the pulses.

Because of the same reason as that described in the
25 first embodiment, the threshold voltage of the field effect

transistor 4 should preferably be higher than the bias voltage of the semiconductor laser chip 1 by 0.2 V to 5.0 V.

EMBODIMENT 4

5 Figure 5(a) is a cross-sectional view of a semiconductor laser device according to a fourth embodiment of the present invention; and Figure 5(b) is a circuit diagram of the semiconductor laser device of the fourth embodiment.

As shown in Figure 5(a), a semiconductor laser chip 1, made of GaAlAs, is provided over a package 3 with a conductive laser mount 2 interposed therebetween. A semiconductor substrate 5, including a diode 8 and a capacitor 11 thereon, is also provided on the package 3. The diode 8 and the capacitor 11 are electrically isolated from each other via an insulating film 9.

As shown in Figure 5(b), the diode 8 and the capacitor 11, connected in series to each other, form a surge absorber. The anode of the semiconductor laser chip 1 is connected to the capacitor 11, i.e., one terminal of the surge absorber, while the cathode of the semiconductor laser chip 1 is connected to the cathode of the diode 8, i.e., the other terminal of the surge absorber.

When a surge voltage is applied to the semiconductor laser device, a surge current flows through the diode 8 by way of the capacitor 11. As a result, the surge current,

supplied to the semiconductor laser device, can be absorbed by the surge absorber.

It should be noted that if the capacitance of the capacitor 11 is increased to decrease the impedance of the surge absorber, then the surge current could be absorbed even more effectively. Also, since the bias voltage is likely to vary or a reference voltage, applied to a laser driver, fluctuates easily if a radio frequency voltage has been superimposed, the bias voltage of the diode 8 is ordinarily 0.2 V or less, which is very small. Since the bias voltage of the diode 8 is that low, the impedance of the diode 8 is larger than that of the semiconductor laser chip 1 during the normal operation of the semiconductor laser device. Accordingly, even if a radio frequency voltage has been superimposed, it is possible to prevent the modulated components from leaking from the laser chip into the surge absorber. Thus, when the semiconductor laser device is modulated with pulses, the waveform of a current flowing through the device and the intensity waveform of output optical power thereof exhibit excellent response at the rise and fall times of the pulses.

EMBODIMENT 5

Figure 6(a) is a cross-sectional view of a semiconductor laser device according to a fifth embodiment of the present invention; and Figure 6(b) is a circuit diagram of the semi-

conductor laser device of the fifth embodiment.

As shown in Figure 6(a), a semiconductor laser chip 1 is provided over a package 3 with a conductive laser mount 2 interposed therebetween. A semiconductor substrate 5, including first and second diodes 8a and 8b thereon, is also provided on the package 3.

As shown in Figure 6(b), the anodes of the first and second diodes 8a and 8b are connected in common. The cathode of the first diode 8a is connected to the anode of the semiconductor laser chip 1. The cathode of the second diode 8b is connected to the cathode of the semiconductor laser chip 1.

In the fifth embodiment, when a surge voltage is applied to the semiconductor laser device, breakdown happens in the first diode 8a connected to the semiconductor laser chip 1 to have mutually reverse polarities. On the other hand, the second diode 8b, connected to the semiconductor laser chip 1 to have the same polarity, is forward biased. As a result, the surge current can be absorbed. In this case, by increasing the junction capacitance (or decreasing the impedance) of the first diode 8a, the surge current can be absorbed even more effectively.

Also, setting the avalanche voltage of the first diode 8a larger than the bias voltage of the semiconductor laser chip 1, if a surge voltage higher than the bias voltage has been

applied, the surge current can be absorbed more effectively. In addition, even if a bias voltage varies or a reference voltage, applied to a laser driver, fluctuates due to the superposition of a radio frequency voltage, the bias voltage of the second diode **8b** hardly changes, although the bias voltage of the first diode **8a** does change. Thus, it is possible to prevent the modulated components from leaking from the laser chip into the diodes even if a radio frequency voltage has been superimposed, for example. Accordingly, when the semiconductor laser device is modulated with pulses, the waveform of a current flowing through the device and the intensity waveform of output optical power thereof exhibit excellent response at the rise and fall times of the pulses.

15 EMBODIMENT 6

Figure 7(a) is a cross-sectional view of a semiconductor laser device according to a sixth embodiment of the present invention; and Figure 7(b) is a circuit diagram of the semiconductor laser device of the sixth embodiment.

20 As shown in Figure 7(a), a semiconductor laser chip **1**, made of GaAlAs, is provided over a package **3** with a conductive laser mount **2** interposed therebetween. A semiconductor substrate **5**, including an n-channel field effect transistor **4** operating in an enhancement mode and a resistor **12** thereon, is also provided on the package **3**. The semiconductor laser

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chip 1 is connected to the field effect transistor 4 and to the resistor 12 by connecting respective wires 6 to associated electrodes 10.

As shown in Figure 7(b), the anode of the semiconductor laser chip 1 is connected to the gate and drain of the field effect transistor 4, while the cathode of the semiconductor laser chip 1 and the source of the field effect transistor 4 are connected to each other via the resistor 12.

The series resistance of the semiconductor laser chip 1, the resistance of the resistor 12 and the on-resistance between the drain and source of the field effect transistor 4 are set at 3Ω , 3Ω and 2Ω , respectively.

In this embodiment, the bias voltage of the semiconductor laser chip 1 is 2 V and the threshold voltage of the field effect transistor 4 is 4 V. When a surge voltage exceeding 4 V is applied to the semiconductor laser device, the field effect transistor 4 starts to operate because the voltage applied to the field effect transistor 4 exceeds the threshold voltage thereof, and a surge current flows through the field effect transistor 4. In this case, a surge current flows through a serial circuit in which the semiconductor laser chip 1 and the resistor 12 are connected in series to each other. The amount of the surge current is determined based on the ratio of the impedance of the serial circuit to the impedance of the field effect transistor 4. Thus, by in-

creasing the resistance of the resistor 12, the surge current flowing through the semiconductor laser chip 1 can be reduced. In this configuration, even if the series resistance of the semiconductor laser chip 1 is fixed, the surge current flowing
5 through the semiconductor laser chip 1 can be controlled only by regulating the impedance of the resistor 12 or the field effect transistor 4.

This sixth embodiment is implemented by modifying the first embodiment through the addition of the resistor 12 to
10 the semiconductor laser chip 1 of the first embodiment. Such a modification is also applicable to the semiconductor laser device of any of the second through fifth embodiments and the same effects are attainable in any case.

As described above, the semiconductor laser device of
15 the present invention includes an electronic device, such as the field effect transistor 4 or the bipolar transistor 7 for absorbing a surge current, on the laser mount 2 or on the semiconductor substrate 5. In this manner, the semiconductor laser device can absorb the surge current without increasing
20 the number of components thereof.

In the embodiments of the present invention, the field effect transistor 4 may be a p-channel transistor, not the n-channel transistor exemplified above, and the bipolar transistor 7 may be a pnp transistor, not the npn transistor il-
25 lustrated above.

The package applicable to the embodiments of the present invention may be of a gang-bonded type or a lead frame type. However, the shape and the material of the package are not especially limited.

5 The semiconductor laser chip may be made of a compound selected from the group consisting of: GaAlAs; InGaAlP; GaN; InGaN; AlGaN; ZnSe; ZnMgSSe; ZnCdSSe; InP; InGaAs; and InGaAsP.

10 In using a compound resulting in a short laser oscillation wavelength such as InGaAlP, GaN, InGaN or AlGaN, the energy of photons is high. Thus, when light is emitted from the semiconductor laser chip made of such a compound upon the application of a surge voltage thereto, the end facets of the semiconductor laser chip 1 are very likely to be optically
15 damaged. According to the present invention, deterioration of a semiconductor chip due to the surge current can be suppressed. Thus, the present invention is particularly effective to semiconductor laser chips made of such compounds as resulting in a shorter laser oscillation wavelength.

WHAT IS CLAIMED IS:

1. A semiconductor laser device comprising:
a semiconductor laser chip including an anode and a cathode; and
a field effect transistor,
wherein the anode is connected to the drain of the field effect transistor, and
wherein the gate of the field effect transistor is connected to the drain of the field effect transistor, and
wherein the cathode is connected to the source of the field effect transistor.
2. The device of Claim 1, wherein the absolute value of a threshold voltage of the field effect transistor is larger than the absolute value of a bias voltage of the semiconductor laser chip.
3. The device of Claim 2, wherein the absolute value of the threshold voltage of the field effect transistor is larger than the absolute value of the bias voltage of the semiconductor laser chip by 0.2 V to 5.0 V.
4. The device of Claim 1, wherein an on-resistance between the drain and the source of the field effect transistor is equal to or less than 5Ω .
5. The device of Claim 1, further comprising a resistor connected to the cathode of the semiconductor laser chip.
6. A semiconductor laser device comprising:



a semiconductor laser chip including an anode and a cathode; and

a bipolar transistor,

wherein the anode is connected to the collector of the bipolar transistor, and

wherein the cathode is connected to the emitter of the bipolar transistor.

7. The device of Claim 6, wherein the absolute value of an avalanche voltage between the collector and the emitter of the bipolar transistor is larger than the absolute value of a bias voltage of the semiconductor laser chip.

8. The device of Claim 7, wherein the absolute value of the avalanche voltage between the collector and the emitter of the bipolar transistor is larger than the absolute value of the bias voltage of the semiconductor laser chip by 0.2 V to 5.0 V.

9. The device of Claim 6, further comprising a resistor connected to the cathode of the semiconductor laser chip.

10. A semiconductor laser device comprising:

a semiconductor laser chip including an anode and a cathode;

a field effect transistor; and

a bipolar transistor,

wherein the anode is connected to the collector of the bipolar transistor, and



wherein the cathode is connected to the emitter of the bipolar transistor, and

wherein the drain of the field effect transistor is connected to the collector of the bipolar transistor, and

wherein the source of the field effect transistor is connected to the base of the bipolar transistor, and

wherein the gate of the field effect transistor is connected to the drain of the field effect transistor.

11. The device of Claim 10, wherein the absolute value of a threshold voltage of the field effect transistor is larger than the absolute value of a bias voltage of the semiconductor laser chip.

12. The device of Claim 11, wherein the absolute value of the threshold voltage of the field effect transistor is larger than the absolute value of the bias voltage of the semiconductor laser chip by 0.2 V to 5.0 V.

13. The device of Claim 10, further comprising a resistor connected to the cathode of the semiconductor laser chip.

14. A semiconductor laser device comprising:

a semiconductor laser chip including an anode and a cathode; and

a surge absorber including a diode and a capacitor that are connected in series to each other,

wherein the anode is connected to one terminal of the surge absorber, and



wherein the cathode is connected to the other terminal of the surge absorber, and

wherein the diode is connected to the semiconductor laser chip to have the same polarity.

15. The device of Claim 14, wherein the impedance of the diode is larger than that of the semiconductor laser chip.

16. The device of Claim 14, further comprising a resistor connected to the cathode of the semiconductor laser chip.

17. A semiconductor laser device comprising:
a semiconductor laser chip including an anode and a cathode;

a first diode including an anode and a cathode; and

a second diode including an anode and a cathode,

wherein the anodes of the first and second diodes are connected in common, and

wherein the anode of the semiconductor laser chip is connected to the cathode of the first diode, and

wherein the cathode of the semiconductor laser chip is connected to the cathode of the second diode.

18. The device of Claim 17, wherein the impedance of the first diode is larger than that of the semiconductor laser chip.

19. The device of Claim 18, wherein a difference between the absolute value of a reverse avalanche voltage of the first diode and the absolute value of a bias voltage of the semicon-



ductor laser chip is larger than 0 V and equal to or smaller than 5 V.

20. The device of Claim 17, further comprising a resistor connected to the cathode of the semiconductor laser chip.

